



#12/A 2814  
6-11-02 #  
Molish

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of )  
)  
Kazuo MAEDA ) Examiner: Quach  
)  
Serial No.: 09/519,599 ) Art Unit: 2814  
)  
Filed: March 6, 2000 )  
)  
For: METHOD AND APPARATUS FOR )  
FORMING AN INTERLAYER )  
INSULATING FILM AND )  
SEMICONDUCTOR DEVICE )

RECEIVED  
JUN - 7 2002  
TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION OF DECEMBER 4, 2001

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Responsive to the office action of December 4, 2001, please amend the captioned application  
as follows:

IN THE SPECIFICATION:

Please substitute the attached "Substitute Specification and Abstract" for the originally filed  
specification and abstract.

IN THE CLAIMS:

Please rewrite claims 1, 5, 6 and 7 as follows: